

0163-0707-2X



IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :

Kenji MIWA et al

: GROUP: 1722

SERIAL NO: 09/158,099

:

FILED: September 22, 1998

: EXAMINER: PACHECO, L.

FOR: METHOD OF REFINEMENT OF :  
MICROSTRUCTURE OF...

7/1/00  
11/27/00

AMENDMENT

ASSISTANT COMMISSIONER FOR PATENTS  
WASHINGTON, D.C. 20231

SIR:

Responsive to the Official Action mailed May 15, 2000, please amend the above-identified patent application, as follows:

IN THE SPECIFICATION

Please amend the specification as follows:

Page 1, lines 1-4, delete in their entirety and substitute therefor:

TITLE OF THE INVENTION

METHOD OF REFINEMENT OF MICROSTRUCTURE OF METALLIC MATERIALS

BACKGROUND OF THE INVENTION

Field of the Invention:;

line 18, delete in its entirety and substitute therefor:

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